



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of:

Sergiy Yakovlevich NAVALA, et al.

Art Unit: 2828

Serial No. 10/755,452

Examiner: H. Philogene

Filed: January 13, 2004

*Confirmation No. 1075*

For: MAGNETRON CATHODE AND  
MAGNETRON SPUTTERING  
APPARATUS COMPRISING THE SAME

Attorney Docket No. 249/439

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office action dated August 10, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in a listing of claims, which begins on page 3 of this paper.

**Remarks** begin on page 7 of this paper.

An **Appendix** including amended drawing figures is attached following page 21 of this paper.